

Docket No.: 43888-087

6P/1743
#4
BH
3/27/02
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Tatsurou KAWAMURA

Serial No.: 09/697,121

Filed: October 27, 2000



Group Art Unit: 1743

Examiner: A. Royall

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For: METHOD FOR MEASURING CONCENTRATION OF SOLUTION AND APPARATUS
FOR MEASURING CONCENTRATION OF SOLUTION

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, DC 20231

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449. It is respectfully requested that the references be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.


This Supplemental Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Each English language reference was cited in a corresponding foreign application search report or office action and its relevance discussed therein. A copy of the foreign search report or office action is attached for the Examiner's information.



Respectfully submitted,

MCDERMOTT, WILL & EMERY


Michael E. Fogarty
Registration No. 36,139

600 13th Street, N.W.
Washington, DC 20005-3096
(202)756-8000 MEF:prp
Facsimile: (202)756-8087
Date: March 18, 2002

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